I hereby certify that this correspondence is being hand delivered to: Commissioner for Patents, 2011 South Clark Place, Room 1803, Crystal Plaza 2, Arlington, Virginia, 22202, on the date shown below.

Dated: September 29, 2003

Signature: (Jeff McCuller)

Docket No.: 506212001200

(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Michihiko YANAGISAWA, et al

Application No.: Not Yet Assigned

Group Art Unit: Not Yet Assigned

Filed: September 29, 2003

Examiner: Not Yet Assigned

For:

MULTI-STEP LOCAL DRY ETCHING METHOD FOR SOI WAFER

INFORMATION DISCLOSURE STATEMENT (IDS)

Commissioner for Patents 2011 South Clark Place Room 1B03, Crystal Plaza 2 Arlington, Virginia, 22202

Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached PTO/SB/08. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement accompanies the new patent application submitted herewith.

A copy of each document on PTO/SB/08 is attached.

While the information and references disclosed in this Information Disclosure Statement may be "material" pursuant to 37 CFR 1.56, it is not intended to constitute an admission that any

patent, publication or other information referred to therein is "prior art" for this invention unless specifically designated as such.

In accordance with 37 CFR 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR 1.56(a) exists. It is submitted that the Information Disclosure Statement is in compliance with 37 CFR 1.98 and the Examiner is respectfully requested to consider the listed documents.

Dated: September 29, 2003

Respectfully submitted

Barry E. Bretschneider Registration No.: 28,055

MORRISON & FOERSTER LLP 1650 Tysons Blvd, Suite 300 McLean, Virginia 22102 (703) 760-7743 PTO/SB/08A (10-01)
Approved for use through 10/31/2002.OMB 0651-0031
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Substitute for form 1449A/PTO				Complete if Known		
•				Application Number	Not Yet Assigned	
11	NFORMATION	اD ۷	SCLOSURE	Filing Date	September 29, 2003	
8	STATEMENT	BY A	APPLICANT	First Named Inventor	Michihiko YANAGISAWA	
1				Art Unit	N/A	
	(use as many sh	eets as	necessary)	Examiner Name	Not Yet Assigned	
Sheet	1	of	1	Attorney Docket Number	506212001200	

Under the Panerwork Reduction Act of 1995, no nersons are more

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No.1	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
	1.	5,254,830	10/19/1993	ZAROWIN et al.	

	FOREIGN PATENT DOCUMENTS						
Examiner	Cite No.1	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant		
Initials*		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)			Passages or Relevant Figures Appear	T⁰	
	2.	JP 2000-031127	01/28/2000			T	
	3.	JP 2000-174004	06/23/2000			一	
	4.	JP 2000-183044	06/30/2000		1	†	
	5.	JP 2000-216366	08/04/2000			\vdash	
	6.	JP 05-335395	12/17/1993			1	

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¹ Applicant's unique citation designation number (optional). ² See attached Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the application number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁹ Applicant is to place a check mark here if English language Translation is attached.

NON PATENT LITERATURE DOCUMENTS.				
Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, page(s), volume-issue number(s), publisher, city and/or country where published.	, T²	

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Examiner	Date
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114 15 166	
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